		N°
	Application No.	Applicant(s)
Notice of Allowability	09/836,258	CHEN ET AL.
	Examiner	Art Unit
	Andy Huynh	2818
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. X This communication is responsive to AMNENDMENT date	<u>d July 12, 2002</u> .	
2. The allowed claim(s) is/are 1-3,5 and 6.		
3. X The drawings filed on 18 April 2001 are accepted by the E	xaminer.	
<ol> <li>Acknowledgment is made of a claim for foreign priority und</li> <li>a) ☐ All b) ☐ Some* c) ☐ None of the:</li> </ol>	ler 35 U.S.C. § 119(a)-(d) or (f).	
1. Certified copies of the priority documents have been received.		
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).		
(a) The translation of the foreign language provisional application has been received.		
6. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		
<ol> <li>A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which gives reas</li> </ol>	nitted. Note the attached EXAMINER on(s) why the oath or declaration is	'S AMENDMENT or NOTICE OF deficient.
8. CORRECTED DRAWINGS must be submitted.		
(a) including changes required by the Notice of Draftsper	son's Patent Drawing Review ( PTO	-948) attached
1) 🗌 hereto or 2) 🔲 to Paper No		
(b) including changes required by the proposed drawing correction filed, which has been approved by the Examiner.		
(c) including changes required by the attached Examiner	s Amendment / Comment or in the G	Office action of Paper No
Identifying indicia such as the application number (see 37 CFR 1 of each sheet. The drawings should be filed as a separate paper	.84(c)) should be written on the drawir with a transmittal letter addressed to	ngs in the top margin (not the back) the Official Draftsperson.
<ol> <li>DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT FOR T</li> </ol>	sit of BIOLOGICAL MATERIAL r HE DEPOSIT OF BIOLOGICAL MA	must be submitted. Note the TERIAL.
Attachment(s)		-
1 ☐ Notice of References Cited (PTO-892) 3 ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	4☐ Interview Summ	al Patent Application (PTO-152) ary (PTO-413), Paper No
<ul> <li>5 Information Disclosure Statements (PTO-1449), Paper No</li> <li>7 Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ul>	6☐ Examiner's Ame 8⊠ Examiner's State 9☐ Other	ement of Reasons for Allowance
Bavid Nelms		
•	Supervisory Patent Examiner Technology Center 2800	

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## **DETAILED ACTION**

In Amendment dated July 12, 2002, Applicants have amended claim 1 and canceled claim 4 in Paper No. 8 is acknowledged. Accordingly, claims 1-3 and 5-6 remain pending in the application.

## Reason for allowance

Claims 1-3 and 5-6 are allowed.

The following is an examiner's statement of reason for allowance: The cited prior art of Wilford (USP: 6,342,723) fails to teach or suggest a bypass circuit for reducing plasma damage to a gate oxide of a metal-oxide semiconductor (MOS) wafer, which comprises the fusion area is composed of polysilicon and is deposited in the conductive wire, composed of tungsten, after the conductive wire is formed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

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## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andy Huynh whose telephone number is (703) 305-0089. The examiner can normally be reached on Monday-Friday 8:30am-5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (703) 308-4910. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 308-7722 for regular communications and (703) 308-7722 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Supervisory Patent Examiner **Technology Center 2800** 

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08/02/02